PAGE 2/18 * RCVD AT 10/3/2006 5:22:55 PM [Eastern Daylight Time] * SVR: USPTO EFXRF-6/33 * DMIS:2738300 * CSID:703 761 2376 * DURATION (mm-ss):04-40

Serial No. 10/680,260

Docket No. YOR920030013US1

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

OCT 0 3 2006

In re Application of

David Abraham et al.

Serial No.: 10/680,260

Group Art Unit: 2814

Filed: October 8, 2003

Examiner: Mai, Anh D.

For: METHOD AND SYSTEM FOR PATTERNING OF MAGNETIC THIN FILMS USING

Honorable Commissioner of Patents

AMENDMENT UNDER 37 C.F.R. \$1.116

In response to the Final Office Action dated August 3, 2006, please amend the above-

identified application as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper. No new matter has been added.

Remarks begin on page 6 of this paper.